



XA-9967
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Atsushi HIRAIWA et al.

Conf. No.: 7336

Appln. No.: 10/695,798

Group Art Unit: 2829

Filed: October 30, 2003

Examiner: C. Everhart

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICES

* * *

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

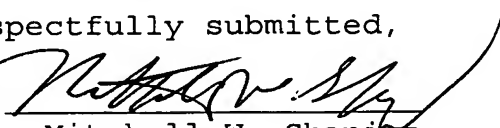
Sir:

It is respectfully requested that the time now set for response be extended, retroactively, by two months. The required petition fee for a large entity is submitted herewith. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 that may be required by this paper to Deposit Account No. 50-1165.

Respectfully submitted,

MWS:sjk

By:


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August 10, 2006